	Туре	Hits	Search Text	DBs	Time Stamp
1	BRS	2	"20040180549"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:33
2	BRS	0	semiconductor adj (wafer substrate) with (grinding thinning) and resin and (electrode electrodes) and ahesive with support and (bump bumps) and (through?hole via)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:35
3	BRS	84	semiconductor adj (wafer substrate) with (grinding thinning) and resin and (electrode electrodes) and (bump bumps) and (through?hole via)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:53
4	BRS	177	semiconductor adj (wafer substrate) with (grinding thinning) and resin same (electrode electrodes)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:46
5	BRS	127	semiconductor adj (wafer substrate) with (grinding thinning) and resin with (electrode electrodes)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:47
6	BRS	4	semiconductor adj (wafer substrate) with (grinding thinning) and resin with (electrode electrodes) and resin with spin?coating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:48
7	BRS	4	semiconductor adj (wafer substrate) with (grinding thinning) and resin same (electrode electrodes) and resin with spin?coating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:48
8	BRS	4	semiconductor adj (wafer substrate) with (grinding thinning) and resin and (electrode electrodes) and resin with spin?coating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:48
9	BRS	102	semiconductor adj (wafer substrate) and resin and (electrode electrodes) and resin with spin?coating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:48
10	BRS	46	semiconductor adj (wafer substrate) and resin with (electrode electrodes) and resin with spin?coating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:48

	Туре	Hits	Search Text	DBs	Time Stamp
11	BRS	13	semiconductor adj (wafer substrate) with (grinding thinning) and resin with (press pressing pressed) and (electrode electrodes) and (bump bumps) and (through?hole via)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:54
12	BRS	13	semiconductor adj (wafer substrate) with (grinding thinning) and resin with (press pressing pressed) and (electrode electrodes) and (bump bumps)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:54
13	BRS	173	semiconductor adj (wafer substrate) and resin with (press pressing pressed) and (electrode electrodes) and (bump bumps)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/11/27 21:54
14	BRS	120	1	USPAT; EPO; JPO; DERWENT;	2004/11/27 21:54
15	BRS	120	(press pressing pressed) and (electrode electrodes) and	= =	2004/11/27 21:54
16	BRS		semiconductor adj (warer substrate) and resin with (thickness beight)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 15:45
17	BRS	577	semiconductor adj (wafer substrate) and support with metal and resin	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 15:42
18	BRS	83	S16 and S17	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 15:42
19	BRS	0	semiconductor adj (warer substrate) and first adj area same second adj are	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 15:45

	Туре	Hits	Search Text	DBs	Time Stamp
20		1471	semiconductor adj (wafer substrate) and first adj area same second adj area	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 15:45
21	BRS	119	semiconductor adj (wafer substrate) and first adj area same second adj area and resin	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 15:47
22	BRS	62	semiconductor adj wafer and first adj area same second adj area and resin		2004/12/05 15:48
23	BRS	880	semiconductor adj wafer and peripheral with (metal resin)	1	2004/12/05 15:53
24	BRS	46	semiconductor adj wafer with (grinding thinning) and peripheral with (metal resin)	1	2004/12/05 15:49
25	BRS	47	semiconductor adj wafer and peripheral adj area with (metal resin)		2004/12/05 15:59
26	BRS	183	semiconductor adj wafer same peripheral adj area	· · · · · · · · · · · · · · · · · · ·	2004/12/05 15:59
27	BRS		F	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2004/12/05 16:04
28	BRS	980	(Deribberal beribbery) and	I	2004/12/05 16:05
29	BRS	533	(peripheral periphery) mear5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 16:05
30	BRS		(peripheral periphery) near5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 16:10

	Туре	Hits	Search Text	DBs	Time Stamp
31	BRS	76	semiconductor adj wafer same (peripheral periphery) and (peripheral periphery) near5 (thickness resin height thick thicker) and resin and electrodes	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 16:10
32	BRS	72	semiconductor adj wafer same (peripheral periphery) and (peripheral periphery) near5 (thickness support height thick thicker) and resin and electrodes	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 16:24
33	BRS	82	semiconductor adj wafer same (peripheral periphery) and (peripheral periphery) near5 (thicker)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/05 16:25
34	BRS	11	semiconductor adj wafer same (peripheral periphery) and (peripheral periphery) near5 (thicker) and resin	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/10 16:51
35	BRS	4160	semiconductor adj wafer and circuit adj board	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/07 22:23
36	BRS	14	semiconductor adj wafer and circuit adj board and chip adj resistor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/07 22:26
37	BRS	330	semiconductor adj wafer and circuit adj board and side with electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2004/12/07 22:29
38	BRS	42	semiconductor adj wafer and chip adj resistor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2004/12/07 22:26
39	BRS	191	semiconductor adj wafer and circuit adj board and side near3 electrode	US-PGPUB;	2004/12/07 22:32
40	BRS	2	"6005474".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/07 22:32
41	BRS	0	1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/10 16:50

	Туре	Hits	Search Text	DBs	Time Stamp
42		0	periphery) and (peripheral periphery) pears (thicker) same	TDO. DEDWENT.	2004/12/10 16:50
43	BRS	4	(peripheral periphery) and (peripheral periphery) near5	l '	2004/12/10 16:57
44	BRS	20	(neripheral periphery) and	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/10 17:04
45	BRS	339	(peripheral periphery) and resin same (peripheral	l '	2004/12/10 16:57
46	BRS	191	(peripheral periphery) and resin with (peripheral		2004/12/10 16:57
47	BRS	93	(peripheral periphery) and resin near5 (peripheral		2004/12/10 16:57
48	BRS	268	(peripheral periphery) and	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/10 17:05
49	BRS	166	(peripheral periphery) and (thicker thick thickness) with		2004/12/10 17:05
50	BRS	116	(peripheral periphery) and (thicker thick thickness) near5 resin	JPO; DERWENT; IBM_TDB	2004/12/10 17:05
51	BRS	93	(peripheral periphery) and (thicker thick thickness) near3 resin		2004/12/10 17:05
52	BRS	78	(peripheral periphery) and (thicker thick thickness) near2	· · · · · · · · · · · · · · · · · · ·	2004/12/10 17:06

	Туре	Hits	Search Text	DBs	Time Stamp
53	BRS	2755	438/106.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	1
54	BRS	1029	438/107.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	
55	BRS	365	438/110.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	1
56	BRS	369	438/111.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	
57	BRS	811	438/113.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2004/12/10 20:42
58	BRS	1313	438/118.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/10 20:42